

Notice of References Cited	Application/Control No. 10/650,461		Applicant(s)/Patent Under Reexamination DAWES, DAVID	
	Examiner Derek L. Dupuis		Art Unit 2883	Page 1 of 1

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	M	US-			

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NON-PATENT DOCUMENTS

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*	V	Beach, R.J. "Theory and optimization of lens ducts", Applied Optics, April 20, 1996, Vol 35, No. 12 (pp 2005-2015)			
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.